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Synthesis and Optical Properties of Large-Area Single-Crystalline 2D Semiconductor WS₂ Monolayer from Chemical Vapor Deposition

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Being entangled in controlling the electronic properties of graphene for next-generation electronics, [1,2] monolayer transition metal dichalcogenides such as MS₂ (M = Mo, W) are attracting great interest as 2D semiconductors with a native direct-energy gap in the visible frequency range.[3,4] Monolayers of other layered materials such as h-BN, GaS, GaSe, TaSe2, and so on, have also attracted much attention because of their unique properties when scaled down to monolayers.^[5-8] There are comprehensive and intensive studies on monolayer MoS2, including its optical and electronic properties, [9-17] valleytronics, [18-21] strain effects, [22-24] thermal effects, [25] and so on. However, investigations of WS2 have just started. Similar to 2H-MoS2, monolayer 2H-WS₂ can be constructed by sandwiching two atomic layers of S and one atomic layer of W through covalent W-S bonds, where W locates at the body center of a trigonal-prismatic case formed by six S atoms. Confinement of charge carriers inside the horizontal atomic plane gradually enlarges energy gaps when thinning WS₂ layers.^[26] Instead of an indirect energy gap for multiple layers, a direct energy gap of ~2 eV at the corners (K and K' points) of the Brillouin Zone could be formed in monolayer WS_2 as clearly demonstrated by both theoretical and experimental studies. [9,27-29] The immediate consequence, also a benefit of the existence of such direct bandgap, is the significant enhancement of visible light emission. In WS₂ monolayers,

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breaking inversion symmetry leads to the strong spin-orbit coupling and the splitting of valence bands at K/K' points with a sub-gap of around 0.4 eV.[30] Furthermore, the split spins at the time-reversed K and K' valleys have the opposite signs. Thus, such spin-valley coupling offers an extra degree of freedom to charge carriers in WS2 monolayers. Though it has not been reported in monolayer WS2, theory predicts and experiments have observed in monolayer MoS2 a non-equilibrium charge carrier imbalance at two valleys, revealed by the remarkable difference of absorption of left- (σ -) and right-handed (σ +) circular polarized lights at the two valleys.^[9,18-21,31] All these interesting and important properties, plus the newly revealed potential in the flexible heterostructures of graphene-WS₂ stacks^[32,33] guarantee a promising future of WS2 as the candidate of nextgeneration nanoelectronics, spintronics, valleytronics, and optoelectronics.^[34] However, compared to graphene, it is very difficult to prepare MS2 monolayers, and atomically thin MS2 flakes made by mechanical exfoliation are much smaller, in fact too small to be well characterized and processed for devices. Most recently, chemical vapor deposition (CVD) has been used to successfully grow large-area single crystals of monolayer MoS₂.[11,35-38] However, the closed count partner—WS₂ single crystalline monolayers—can only be synthesized by CVD with dimensions of a few micrometers. There are other methods such as intercalation or hydrothermal methods which have been used to synthesize WS₂ monolayers.^[39] In this communication, we report the growth of large-area triangular single crystals of WS₂ monolayer (up to hundreds of micrometers) with high optical quality via a one-step direct sulfurization of WO₃ powders, and we probe their optical properties.

As illustrated in Figure 1a, the growth process is very different with the previously reported CVD growth of WS₂ thin flakes.^[40] Without the pre-deposition of WO₃ thin film in a high-vacuum chamber, in this work, rather than by a two-step process, we fabricate large-area single crystalline WS2 monolayers by one step: the direct sulfurization of WO₃ powders by sulfur powders at 750 °C (the detailed growth mechanism is proposed below). The substrates used here are well cleaned 300 nm SiO₂/Si wafers. One SiO₂/Si substrate is covered with some WO₃ powders with another piece of blank SiO2/Si substrate placed face down above it, and this is then heated in a small one-end sealed quartz tube inside a big quartz tube by a tube furnace. Figure 1b,c, and d present optical microscopy, scanning electron microscopy (SEM), and atomic force microscopy (AFM) images, respectively, of our CVD-grown WS2 flakes on the substrate. It can be clearly seen that atomically thin flakes with a

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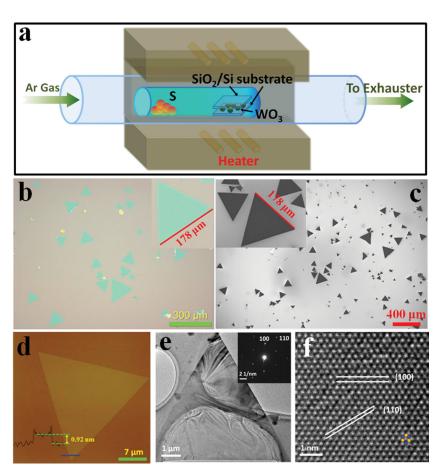


Figure 1. (a) Schematic diagram of the CVD system used for the growth of WS2. (b) Optical image of as-grown WS2 on SiO2 (300 nm)/Si substrate. Inset shows a triangular monolayer WS2. (c) SEM image of the area shown in (a). (d) AFM image of a monolayer WS2. The height profile demonstrates the as-grown WS2 flakes are monolayers. (e,f) Low- and high-magnification TEM images of triangular WS2 monolayer, respectively. Optical, SEM, AFM, and TEM images show the perfect triangular shape and sharp edges (at the microscale) of the as-grown WS2 monolayers.

perfect triangular shape and sharp edges are effectively formed on the 300 nm SiO₂/Si substrate through the CVD process. It is noted that, though triangular WS2 monolayers can be readily formed on both bottom pieces which contain WO3 powders and on the covering pieces which are blank, the WS₂ monolayers grown on the covering substrates are much cleaner and appear as isolated perfect triangles (Figure 1b,c). This could be due to the existence of WO₃ powders and highly concentrated reaction sources on the bottom substrates (see Supporting Figure S1). Due to the sensitivity to the local environment of the CVD growth, the distribution of dimensions of the triangular crystals is quite wide, from a few to hundreds of micrometers, while the majority of the flakes are more than 100 micrometers large. The wide distribution of sizes is also observed in the previously reported CVD growth of MoS₂ and WS₂.[35,36,40] The zoomed-in optical, SEM, and AFM images show the clean surface of the WS2 flakes, which is very different to the MoS2 and WS₂ thin layers grown by CVD previously,^[36,40] where impurities or small second or even multiple layers existed on top of the monolayers. The thickness of these triangular crystals is

determined by the height profile of AFM and Raman spectroscopy (discussed later). Figure 1e,f present the transmission electron microscopy (TEM) study of the WS2 monolayers. As with the optical, SEM, and AFM images, a typical low-magnification TEM image (Figure 1e) visualizes the perfect triangular shape and sharp edges of the as-grown WS₂ monolayers. The high-resolution TEM (HRTEM) image (Figure 1f) reveals the hexagonal ring lattice consisting of alternating tungsten atoms (dark dots) and sulfur (gray dots) atoms as schematically illustrated by the blue and yellow spheres. The TEM data also reveal that the sharp edges are at the microscale perpendicular to the [100] crystalline direction. Though the microscale edges are along the zigzag direction, it should be noticed that our HRTEM image near the edge shows that the edge is not atomically sharp, which ends up with the triangle-like features of a few nanometers (see Supporting Figure S2). A detailed study at the atomic level is needed. All data unambiguously show that the as-grown triangular WS2 flakes are monolayer. The large dimension, perfect triangular shape, and clean surface indicate the WS2 monolayers formed in this work could be a perfect candidate for studying fundamental knowledge and developing practical applications of 2D semiconductors.

Raman spectroscopy has been widely used to study 2D materials, such as the determination of numbers[41-46] and stacking sequence[47-49] of layers, the external field and molecular doping effects,[50,51] and the internal and external strain. [23,24,52-56] Figure 2a shows Raman spectra of the asgrown WS₂ monolayer over a frequency

range of 80–650 cm⁻¹ at room temperature with laser excitation at 532 nm. Fifteen Raman modes of WS₂ are present, as labeled, including the first order modes of LA(M), LA(K), $E_{2\sigma}^1(\Gamma)$ $E_{2\sigma}^1(M)$ and $A_{1g}(\Gamma)$ the second-order mode of 2LA(M), and some combinational modes. The frequency separation of 62.2 cm⁻¹ between the $E_{2g}^1(\Gamma)$ and $A_{1g}(\Gamma)^{[40]}$ and the strong 2LA(M) mode at a laser excitation of 532 nm caused by the double resonance scattering could be the spectral fingerprint of monolayer WS2. [57] The Raman images (Figure 2b) plotted by extracting the intensity and position of the $A_{1g}(\Gamma)$ mode also clearly show the perfect triangular shape and uniform thickness of the as-grown WS2 monolayers.

Figure 2d presents the fluorescence (FL) image of the asgrown WS2 monolayers (their optical images are shown in Figure 2c). It can be clearly seen that triangular WS2 monolayers emit strong red luminescence, resulting from the direct energy gap in such monolayers, and that the intensity of the light emission gradually decays from the edges to the body centers of the triangles. These observations demonstrate that the light emission yield of the CVD WS2 monolayers is

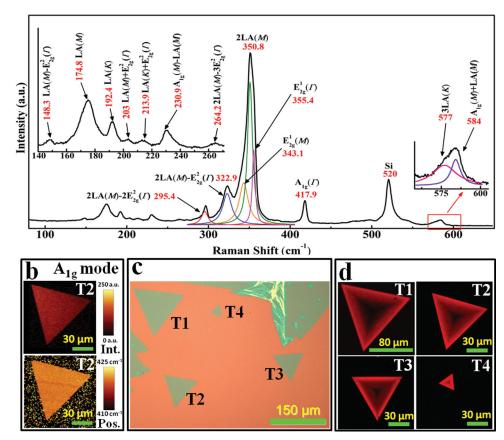


Figure 2. (a) Raman spectra of a WS2 monolayer at room temperature. (b) Raman image of a triangular single crystal of WS2 monolayer constructed by plotting A_{1g} mode intensity (upper panel) and peak position (lower panel). (c) Optical image of as-grown WS₂ on SiO₂ (300 nm)/Si substrate. (d) Fluorescence images of the as-grown WS₂ flakes shown in the optical image of (c).

extremely high and the FL image could be a quick and efficient tool to study such 2D direct energy-gap semiconductors.

To probe the details of light emission from the CVD WS2 monolayer, micro-photoluminescence (PL) spectroscopy is used and the PL spectra from the edge to the body center are plotted in Figure 3a. Not only the intensities, but also the peak position and peak width of the PL vary from the edge to the center. As shown, a blueshift together with quenching of the PL appears from the center relative to that of the edge. To explore this nonuniformity across the monolayer, we conducted PL mapping. Figure 3b shows the corresponding PL intensity image of the triangular WS2 monolayer. As reflected in the FL image, the edges emit the strongest light, and the strength of the emission gradually decays when moving towards the body center, and eventually becomes relatively "dark". The PL line scanning profiles of the location marked by the lines in Figure 3b-d are shown in Figure S3, which displays a detailed evolution of PL intensity, peak width, and peak position from the edge to the body. Though there is the reduction of light emission intensity from edges to body center, the overall PL, even from the body of the WS2 monolayer, is comparable to the PL of the mechanically exfoliated WS2 (MC-WS2) monolayer, and is much stronger than that of the mechanically exfoliated MoS₂ (MC-MoS₂) monolayer, as shown in Figure 3f,h,j. It is noted that samples of even better quality can be formed by controlling the location and heating duration of the sulfur powder. For example, by heating the sulfur powders loaded at the upstream and outside of the furnace heating zone, WS2 monolayers with uniform light emission (as strong as the light emitting from MC-WS₂ monolayers) over the entire triangles were obtained (see Supporting Figure S4). It is also noticed that a weak peak located at around 525 nm, around 0.4 eV higher than the dominant A exciton peak, is present in the PL spectrum of the WS₂ monolayer under the excitation laser of 457 nm (see Figure 3k), which is the so-called the B exciton emission. [28,29] The observation of a B exciton peak, which was not seen in the CVD-grown WS₂ monolayers reported previously,^[40] further demonstrates the high optical quality of our large-area WS2 monolayers and strong spin-orbit coupling. Another consequence, also a great benefit of such strong spin-orbit coupling in MS₂ monolayers, is the presence of valley-selective circular dichroism, which offers promising practical potential in valleytronics. Circularly polarized PL is an effective way to probe the valley dependence. Supporting Figure S5 presents the circularly polarized PL spectra of mechanically exfoliated MoS2 and the CVD-grown WS₂ monolayers under an excitation laser of 633 nm. The incident light is fixed as left-handed circularly polarized, while the emitting light is selectively collected from left- and right-handed circularly polarizations. The net degree of the circular polarization is also plotted. As expected, an obvious valley-selective circular dichroism could be clearly observed in the CVD-grown WS₂ monolayer even at room temperature.

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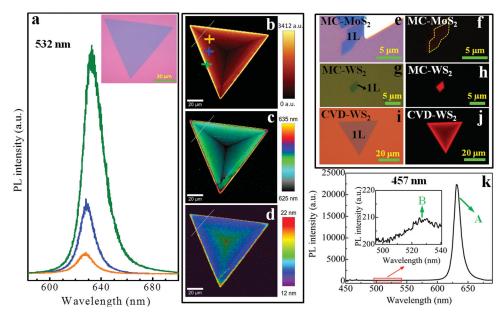


Figure 3. (a) PL spectra of the corresponding (colors) points shown in (b). The inset of (a) shows the optical image of the monolayer WS2 flake studied here. (b-d) PL images of the peak integrated intensity, position, and width, respectively. The lines indicate the locations for the PL line scanning investigation (see Supporting Figure S3). (e,g,i) Optical images of mechanically exfoliated MoS2 (MC-MoS2), and WS2 (MC-WS2) monolayer, and CVD-WS2 monolayer. (f,h,j) The corresponding fluorescence (FL) images of the samples shown in (e,g,i). The FL images are taken under the identical conditions for MoS2 and WS2 monolayer flakes. The bright FL image indicates the ultrahigh quantum yield of direct bandgap light emission from our CVD-grown WS2 monolayers. (k) PL spectrum of CVD WS2 monolayer excited by 457 nm laser. The B exciton peak can be clearly seen in the inset.

As predicted and observed, the monolayer WS2 possesses a direct energy gap of ~2 eV.[9,27-29] The strong PL peaks locating at 635 nm for the edges and 625 nm for the center are from the exciton emission. The blueshift and the suppressing of PL at the center might be due to the existence of structural and charged defects, such as S-vacancies, as such a defect may cause n-type doping in the WS₂ monolayer.^[58,59] The sulfurization of WO_3 powders to produce WS_2 nanostructures has been widely adopted. [40,60] Recently, a modified two-step CVD process was used to grow nanometer and micrometer WS2 monolayers on SiO₂/Si substrates at 800 °C. [40] In this work, we developed a CVD process to grow hundreds of micrometer triangular single crystals of WS2 monolayers on clean and blank 300 nm SiO2/Si substrates. In general, WO₃ powders on one SiO₂/Si substrate together with another piece of covering blank SiO₂/Si substrate were heated in a small-diameter one-ended sealed quartz tube inside a big-diameter quartz tube by a tube furnace. To sulfurize the WO3, sulfur powder was introduced into the upstream part of the quartz tube, where the temperature is around 200–250 °C. Different from the process reported previously,[40] we used a one-end sealed inner quartz tube, which was pre-cleaned by isopropyl alcohol (IPA) and deionized water, inside a big quartz tube, which could effectively increase the concentration and pressure of vapor source for growth. During the whole process, argon gas flowed at a rate of 100 sccm. We propose the mechanism of such a CVD process for the growth of large-area WS2 monolayers as the following: Firstly, flakes of WOvS2-v were formed. Then, further sulfurization produces triangular shaped thick WS_{2+x} flakes with a mixture of W_{IV} and W_{VI} . As the apex of the triangles could be very active sites for nucleation, a series of triangles formed and merged into a big triangle. With continuous heating, the thick WS_{2+x} flakes started expanding and thinning, and eventually WS2 monolayers were fabricated. The formation of thin layers of WS2 started at the center of the thick triangles, since there were less overlapping small triangles here and exposure to sulfur for the longest duration. It should be noted that such center areas are also the most exposed regions after the sulfur source is exhausted during the final heating and cooling stages, which may cause a loss of the sulfur in the monolayers. The whole growth process can be well understood by the images presented in Figure 4. Figure 4a-d is the schematic diagram illustrating the growth of the WS₂ monolayer. Figure 4e-h show optical images of the products at different growth stages, which usually can be simultaneously seen in one substrate, indicating that the growth is very sensitive to the local environment. The formation of WS2+z at the thick parts are firmly proven by energy dispersion spectroscopy (EDS) and time of flight secondary ion mass spectrometry (TOF-SIMS) images shown in Supporting Figure S6. The EDS data indicate the ratios of W to S at the thick edge and thin body are 1:2.6 and 1:1.9, respectively. It is well known that W_{VI} cannot be directly sulfurized by S unless some intermediates are formed.^[61] Therefore, we think the transferring of W_{VI} to W_{IV} at the initial growth stage facilitates the growth of large-area single crystals of WS2 monolayers under a relatively relaxed condition. A more systematic study of the growth mechanism is ongoing.

We have demonstrated the growth of large-area triangular single crystals of WS2 monolayers up to hundreds of micrometers in size by chemical vapour deposition through a single step of direct sulfurization of WO₃ powders, and their optical properties have been probed. The observations of high yield of light

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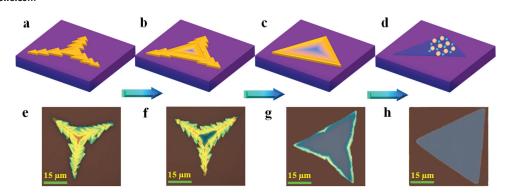


Figure 4. (a-d) Schematic diagram illustrates the growth of WS2 monolayers. (e-h) Optical images of the flakes at the different growth stages. Note: the flakes are not the same piece.

emission and valley-selective circular dichroism provide experimental evidence of the high optical quality of the WS2 monolayers. This work paves the way to exploit the great potential of WS₂ for future optoelectronics and facilitates fundamental studies of single crystalline 2D transition metal dichalcogenides.

GmbH) using 50 KeV Bi3++ as ion beam. The lateral resolution for SIMS imaging is 100 nm. EDS measurements were carried out using an Energy-dispersive X-ray analysis (EDX, Oxford Instruments) integrated with a Carl Zeiss Auriga system. 80 mm silicon-drift detector enables rapid determination of elemental compositions and acquisition of compositional maps.

Experimental Section

Growth Procedure: WS2 monolayer flakes of fine triangular shape were grown by CVD method on well cleaned 300 nm SiO₂/Si substrates. In general, commercial WO₃ powders (>99.5%, Sigma Aldrich) of 1 mg were spread on one piece of SiO₂/Si substrate and another piece of blank wafer was placed face-down above (2-3 mm) the bottom piece. They were then loaded into a small diameter quartz tube sealed at one-end which was pre-cleaned by IPA and deionized water. The small diameter quartz tube with 100 mg of sulfur powders (>99.95%, Sigma Aldrich) located at the upstream part of it was introduced inside a big diameter quartz tube heated in a tube furnace. The furnace was heated firstly to 550 °C, then 750 °C with ramping rates of 20 °C/min and 3 °C/min, respectively. After the temperature was kept at 750 °C for 5 min, the furnace was cooled down to room temperature naturally. Ultra-high purity argon gas was flowed with the flowing rate of 100 sccm during the whole growth process.

Optical and Electronic Microscopy Study: The PL/Raman mappings/ spectroscopies presented in this work were obtained by using a WITec Raman system with a piezocrystal controlled scanning stage. Lasers of 457 nm ($E_{laser} = 2.71$ eV), 532 nm ($E_{laser} = 2.33$ eV) and 633 nm $(E_{laser} = 1.96 \text{ eV})$ were used as the excitation sources. To avoid heating effect, the laser power at sample surface was controlled below 50 μ W. The laser spot size is estimated to be 500 nm. A 100x objective lens with numerical aperture of 0.95 was used for normal PL/Raman measurement. Circularly polarized PL was performed by directing the linearly polarized laser passing through a quarter-wave plate to generate a circularly polarized light. The polarization of the incident light was set to be σ . The polarization σ - or σ + of backscattered PL was analyzed by a linear polarizer after the quarter-wave plate. A long-working distance 50x objective lens and a temperature controlled stage HFS600E from Linkam Scientific Instruments were used for circularly polarized PL measurement. The fluorescence images were obtained by an Olympus fluorescence microscope with a Mercury lamp as the excitation light source. The morphologies of as-grown WS2 monolayer flakes were characterized by field emission scanning electron microscopy (FE-SEM, JEOL JSM-6700F). High-resolution TEM was carried out using an image aberration-corrected TEM system (FEI Titan 80-300). An acceleration voltage of 80 kV was chosen to achieve enough resolution while maintaining the structure of WS2.

EDS and TOF-SIMS: TOF-SIMS study of the as-grown WS2 monolayer flakes on SiO_2/Si substrate was performed on TOF-SIMS⁵ (ION-TOF

Supporting Information

Supporting Information is available from the Wiley Online Library or from the author.

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